Bipolar Device SPICE Modeling Service Questionnaire

Please fill out the following questionnaire. The data you provide in this form is necessary for Silvaco to supply you with high quality SPICE models.

Contact Person in Your Company	Bias Conditions Please specify the typical operating and maximum to apply for MODELING purposes. (Make sure the specified maximum bias conditions are not destructive over the temperature.)					
(for technical questions)						
NAME:						
COMPANY:	NPN Vertical PNP Lateral PNP					
PHONE:	Operating VCE (V):					
FAX:	Operating IC _{max} (A):					
EMAIL:	Operating IC _{min} (A):					
	Maximum VCE (V):					
Package Part or Wafer Information:	Please include measured data plots of: IC/VCE (5 IB steps), Gummel					
For packaged parts please specify package type:	Plot (IC, IB vs. VBE) and BF vs. IC.					
For wafer, please specify: How many wafers will be supplied?:	Temperature Conditions Please specify the temperature points for devices to be characterized? (For example: 0 C, 27 C, 85 C):					
Wafer #:						
Lot#:	Please specify the temperature range for model validation					
Are the devices in a scribeline or in a drop-in test die?:						
	-					
Model Type	Test Chin Information					

Please specify the SPICE model type (For example: Gummel Poon, VBIC95, Mextram)

Please specify the circuit simulator(including the version number) for which the models are generated.

rest unip information

Please specify the Emitter, Base, Collector areas and RSH for the specified regions.

		NPN		Vertical PNP			Lateral PNP			
	E	В	С	Е	В	С	Е	В	С	
Area							_			
RSH										

AC Modeling

AC modeling of Bipolar devices requires the s-parameters to be measured and FT to be extracted. Silvaco can provide s-parameter measurements on packaged part or on wafer. On wafer measurements provide more accurate results and are necessary for devices with FT greater than 1GHZ. For on wafer FT measurements the bipolar devices should be layed out as common emitter configuration (Figure 1). In addition to the actual device an open device structure should be layed out for proper calibration (Figure 2). Base to Emitter and Collector to Emitter pad distance should be 150 μm. (from middle of pad to middle of pad)

Are there special structures (as described above) to measure FT on wafer? (If yes, please indicate the location of these structures on the test chip.)

What is the expected range for FT?

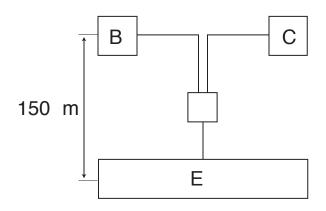


Figure 1. Device layout for FT measurements.

Deliverables

In addition to the SPICE model parameter set and project report the following measured vs simulated data plots are provided:

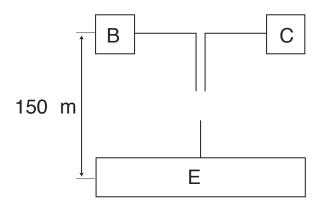


Figure 2. Device open for calibration.

If you have any questions please contact:

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